

Notice of References Cited	Application/Control No. 10/757,095	Applicant(s)/Patent Under Reexamination ATTIA ET AL.	
	Examiner John J. Park	Art Unit 2876	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,512,919	01-2003	Ogasawara, Nobuo	455/422.1
	B	US-6,837,432	01-2005	Tsikos et al.	235/462.01
	C	US-6,585,157	07-2003	Brandt et al.	235/462.07
	D	US-6,674,919	01-2004	Ma et al.	382/289
	E	US-2002/0084330	07-2002	Chiu, Ming-Yee	235/462.11
	F	US-2001/0041581	11-2001	Hansson, Magnus	455/550
	G	US-2003/0055675	03-2003	Klein Twennaar, Robbert Frank	705/1
	H	US-2003/0074286	04-2003	Rodrigo, Anthony	705/32
	I	US-2002/0187774	12-2002	Ritter et al.	455/414
	J	US-2002/0071076	06-2002	Webb et al.	349/117
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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